

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
(Case No. 98,162-B)

In re Application of: )

DeGendt, et al. )

Serial No.: 09/207,546 )

Filed: December 8, 1998 )

For: METHOD FOR REMOVING ORGANIC )  
CONTAMINANTS FROM A )  
A SEMICONDUCTOR SURFACE )

Group Art Unit: 1746

Examiner: Ahmed

Commissioner for Patents  
Washington, D.C. 20231

**PRELIMINARY AMENDMENT**

Dear Sir:

In response to the outstanding Office Action mailed March 22, 2001, please enter the following remarks and amendments in the above-referenced patent application.

**IN THE CLAIMS**

Please amend claim 27 as follows. A marked up version of the amended claim, to show all the changes, is attached hereto on pages separate from the amendment in accordance with 37 CFR 1.121(c)(1)(ii).

27. (Amended) A method for removing organic contaminants from a substrate, the organic contaminants resulting from a previous lithographic step, the method comprising the steps of:

holding said substrate in a tank; and

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